

Surface Profilometer: Zeta-20 Optical Profiler



Step height	3D step height from nanometers to millimeters
Texture	3D roughness and waviness on smooth to very rough surfaces
Form	3D bow and shape
Stress	2D thin film stress
Film thickness	Film thickness from 30nm to 100µm
Defect inspection	Capture defects greater than 1µm

Applications

- Non-contact 3D profiling and imaging device
- Form and roughness measurement
- Measure step height ranging from nm to mm
- True Color 3D Imaging